

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Yoshihisa YAMASHITA et al.

Serial No. NEW

Filed December 27, 2001

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Attn: Application Branch

Attorney Docket No. 2001_1854A

JC927 U.S. PTO

10/026522



Handwritten notes: #740, 103, 12, 251

LEAD FRAME AND PRODUCTION PROCESS
THEREOF AND PRODUCTION PROCESS OF
THERMALLY CONDUCTIVE SUBSTRATE

CLAIM OF PRIORITY UNDER 35 USC 119

Assistant Commissioner for Patents,
Washington, DC 20231

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2000-397650, filed December 27, 2000, and Japanese Patent Application No. 2000-397651, filed December 27, 2000, as acknowledged in the Declaration of this application.

Certified copies of said Japanese Patent Application are submitted herewith.

Respectfully submitted,

Yoshihisa YAMASHITA et al.

By

Michael S. Huppert
Registration No. 40,268
Attorney for Applicants

MSH/kjf
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
December 27, 2001

ARTIFACT SHEET

Indicate quantity of item(s) received by the USPTO but not scanned.

☒ Priority Document No. 2000-37650 Country JP
Doc Code: FRPR

☐ CD(s) containing computer program listing
Doc Code: Computer

☐ Stapled Set(s) of Extra Color Drawings
Doc Code: Artifact

☐ CD(s) containing pages of specification ☐
and/or sequence listing ☐
Doc Code: Artifact

☐ CD(s) with content unspecified
Doc Code: Artifact

☐ Microfilm(s)
Doc Code: Artifact

☐ Video tape(s)
Doc Code: Artifact

☐ Other mass storage media, description: _____
Doc Code: Artifact

☐ Model(s)
Doc Code: Artifact

☐ Other, description: _____
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